Form PTO-1449 (Modified)		0 5 2003		Atty Doc	Atty Docket No.			Serial No.			
LICT	OF DATENTS AND	DEE 0 5 2003		H1631			10/654,739				
FOR APPLICATIONS INFORMATION DISCLOSURE STAFFEMENT					Applicant:						
INFOR	MATION DISCLOSE	Hung-eil Kim et al.									
(Use several sheets if necessary)				Filing Date			Group				
(COC COTOIGN GROUND IN FRANCE)				9/3/2003			Unknown				
			0.0177117.0	0011145117							
Examiner	U.S. PATENT D  Document Number Date Name			OCUMENT	S	Cla	SS	Sub-	Filing Da	te if	
Initial ,								dass	Appropri		
	5,242,770	9/7/1993	Chen et	et al.							
10 N	5,636,002	6/3/1997 Gai		ılo							
	5,674,773	574,773 10/7/1997		Koh et al.							
	6,515,329	2/4/2003	Lee et a	ı <b>l.</b>							
7	6,521,522	2/18/200	3 Cho								
FOREIGN PATENT DOCUMENTS											
Examiner Initial	Document Number	Date	· Country	Country	Class	iss	Sub- class	Translation			
								Yes	No		
							,				
								Vi			
OTHER ART											
Examiner Initial	Author, Title, Date, Pertinent Pages, etc.										
De	Levenson et al., "The Vortex Mask: Making 80nm contacts with a twist!"										
EXAMINER			DATE CONSIDERED April - 2004								
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											
	Information Disclosure Statement PTO-1449 (Modified)										

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

Z:\SEC154\MDS\AMDS\H1631us\ptoform.wpd (IDS1449.FRM) (2/97)